



10-30-91
Docket No. 0756-2247 2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Osamu NAKAMURA et al.

Serial No. 09/748,121

Filed: 12/27/2000

For: METHOD OF MANUFACTURING OF A
SEMICONDUCTOR DEVICE

Art Unit: 2812

Examiner: Unassigned

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 8/16/2001.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

Washington, D.C. 20231

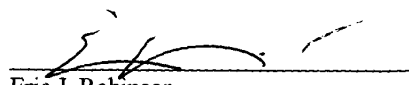
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

US 6,156,628 is in the family of JP 11-040499.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,


Eric J. Robinson
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